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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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E.L.
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C. Stang
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In re United States Patent Application of:)

Applicants: Michael A. Tischler)

) Examiner: Wai Sing Louie

Serial No.: 10/022,316)

) Group Art Unit: 2814

Date Filed: December 18, 2001)

Title: WAFER CARRIER FOR
SEMICONDUCTOR PROCESS TOOL)

TECHNOLOGY CENTER 2000

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AMENDMENT AND RESPONSE

Commissioner for Patents
Washington, D.C. 20231

In response to the Office Action dated November 20, 2002, Applicants respectfully request entry of the following Amendments and consideration of the subsequent remarks.

IN THE CLAIMS

Please amend claims 1, 4-6, 8, 9, 12, 14, and 16-19 and cancel claims 2, 3, 7, 13, and 20-70 as indicated.

1. (Amended) A wafer carrier for coupling to a process tool and having a recess to accommodate a first wafer of a first size and a second wafer of a second size different than the first size.

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